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PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10042264	FILING DATE 01/11/2002	CLASS 257	SUBCLASS 215 316	GAU 2826 2011	EXAMINER Dickey
**APPLICANTS: Inaba Satoshi;					
**CONTINUING DATA VERIFIED:					
** FOREIGN APPLICATIONS VERIFIED: JAPAN 2001-010449 01/18/2001					
PG-PUB DO NOT PUBLISH <input type="checkbox"/>		RESCIND <input type="checkbox"/>			
Foreign priority claimed 35 USC 119 conditions met		<input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> yes <input type="checkbox"/> no		ATTORNEY DOCKET NO P 284163 01F181	
Verified and Acknowledged Examiners's initials					
TITLE : Semiconductor device and method of fabricating the same					

U.S. DEPT. OF COMM./PAT. & TM.-PTO-436L (Rev. 12-84)

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED		
		Assistant Examiner	Total Claims	
			Print Claim for O.G.	
ISSUE FEE		Primary Examiner	DRAWING	
Amount Due	Date Paid		Sheets Drawg.	Print Fig.
<input type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE	Application Examiner	
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